TS01-603 Serial number 10/043,863



465

AUG 0 4 2003 W

TO: Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From : George O. Saile (Reg. No. 19,572)

28 Davis Avenue

Poughkeepsie, NY 12603

#4A 8 R/Q m

Date: June 06, 2003

REF: APPLICANT : Chung-Liang Chang

SERIAL NO. : 10/043,863

ART UNIT : 1765 FILING DATE : 01/10/02 ATT'Y NO. : TS01-603

EXAMINER : Chen, Kin Chan

TITLE : IMPROVEMENT OF PHOTORESIST

SCUM FOR COPPER DUAL DAMASCENE

PROCESS

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to an office action mailed on 05/01/03 please consider the following amendments and remarks with respect to the above referenced application.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelop addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

George Oisaile (Reg. No 19,542)

Signature

Date